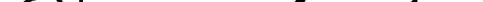


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				Application Number	to be assigned
				Filing Date	January 29, 2004
				First Named Inventor	M. Nakasaji
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				Examiner Name	to be assigned
Sheet	2	of	2	Attorney Docket Number	011470A

NON PATENT LITERATURE DOCUMENTS						
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				T ²
<i>CR</i>	1	Sandland; "An Electron-beam inspection system for x-ray mask production", J. of Vacuum Sci & Tech.B (1991) Vol. 9, No. 6; pp3005-3009				
<i>CR</i>	2	Meisburger et al; "Requirements and performance of an electron-beam column designed for x-ray mask inspection"; J. of Vacuum Sci & Tech.B (1991) Vol. 9, No. 6; pp 3010-3014				
<i>CR</i>	3	Lischke et al; "Multi-beam concepts for Nanometer Devices"; JP J. Applied Physics (1989) Vol. 28, pp 2058-64.				
<i>CR</i>	4	Electron/Ion Beam Handbook 2nd; Nikkan Kogyo (1988) pp 115-119 (with partial English Translation).				
<i>CR</i>	5	U.S. Patent Application S.N. 09/985,323; filed 11/2/2001; Mamoru Nakasaji et al; "Electron Beam Apparatus and Device Production Method Using the Electron Beam Apparatus"				
<i>CR</i>	6	U.S. Patent Application S.N. 09/985,324; filed 11/2/2001; Toshifumi Kimba et al; "Apparatus for Inspecting Material with Electron Beam, Method for Operating Same, and ..."				
<i>CR</i>	7	U.S. Patent Application S.N. 09/985,325; filed 11/2/2001; Mamoru Nakasaji et al; "Electron Beam Apparatus and Method of Manufacturing Semiconductor Device Using the ..."				
<i>CR</i>	8	U.S. Patent Application S.N. 09/985,331; filed 11/2/2001; Mamoru Nakasaji et al; "Method for Inspecting Substrate,Substrate Inspecting System and Electron Beam Apparatus"				

Examiner Signature	<i>D. Miller / D. Johnson</i>	Date Considered	10 - 8 - 04
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